

Title: Method of Manufacturing Single-Crystal Semiconductor Wafers and Laser
Machining Apparatus Therefor

1 of 5

FIG. 1

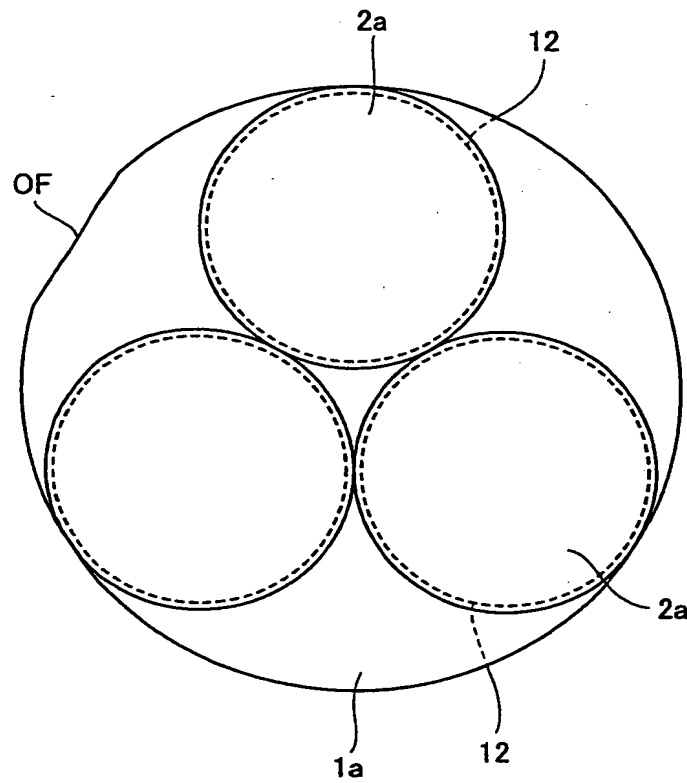


FIG. 2

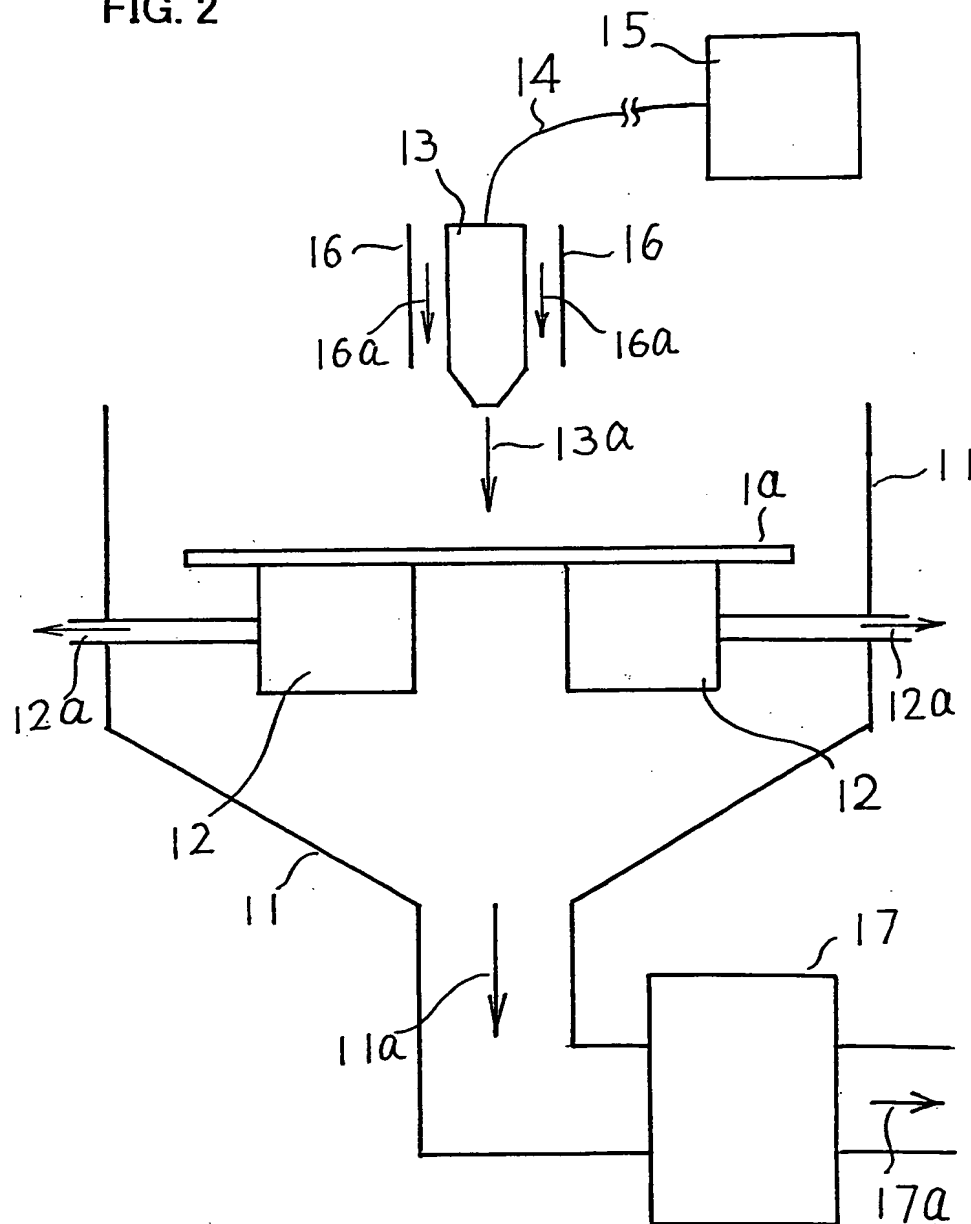


FIG. 3

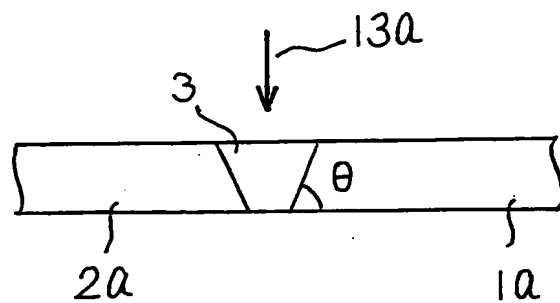


FIG. 4

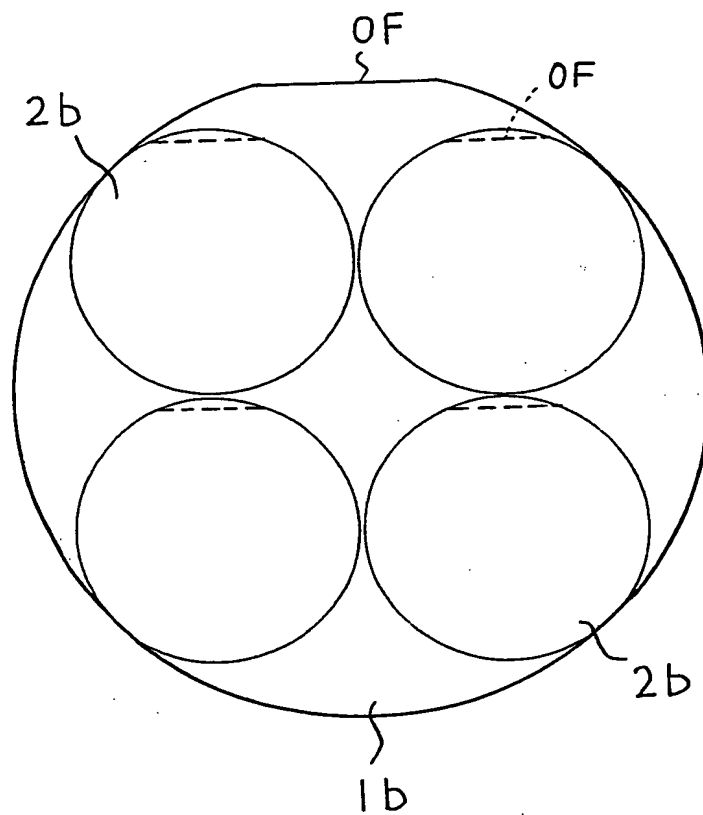


FIG. 5

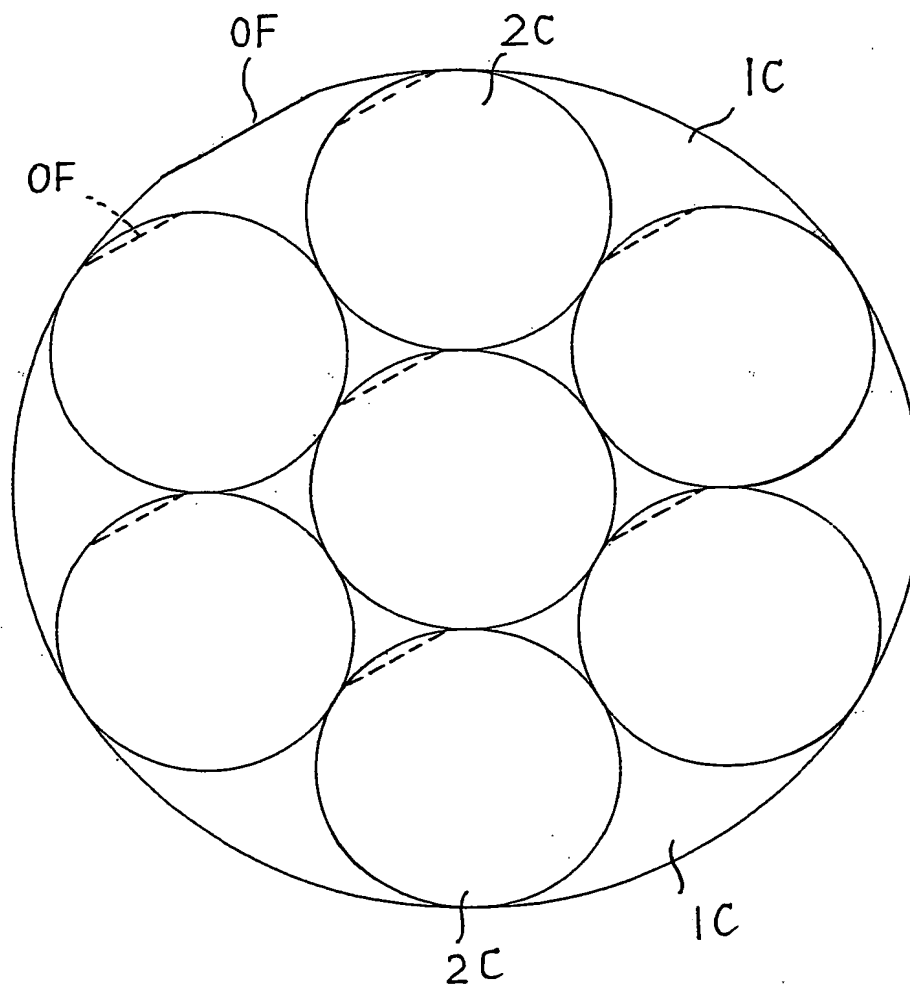


FIG. 6

